Paper No._____

UNITED STATES PATENT AND TRADEMARK OFFICE

BEFORE THE PATENT TRIAL AND APPEAL BOARD

TAIWAN SEMICONDUCTOR MANUFACTURING COMPANY, LTD. (TSMC) and SAMSUNG ELECTRONICS., LTD Petitioner

v.

DSS TECHNOLOGY MANAGEMENT, INC. Patent Owner

> Patent 5,652,084 IPR2014-01030¹

Title: METHOD FOR REDUCED PITCH LITHOGRAPHY

NOTICE OF DEPOSITION OF DR. CHRIS A. MACK, Ph.D.

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¹ Case IPR2014-01493 has been joined with this proceeding.

Please take notice that, pursuant to 37 C.F.R. § 42.53(d), the Federal Rules

of Civil Procedure, the Scheduling Order entered in the above-captioned matter,

and the Joint Stipulation filed Feb. 27, 2014, Petitioners will take the deposition

upon oral examination of Dr. Mack.

The deposition will commence at:

Place:	Law Offices of Nix Patternson & Roach
	5215 North O'Connor Road
	Suite 1900
	Irving, TX
Time:	Thursday, May 14, 2015 at 9:00 a.m.

Deponent: Dr. Chris A. Mack

or at such other time and place as the parties may mutually agree upon. The

deposition will be recorded stenographically and may be recorded by video.

You are invited to attend and cross-examine.

Dated: <u>April 8, 2015</u>

Respectfully submitted,

/David M. O'Dell/ David M. O'Dell Lead Counsel for Petitioner TSMC Registration No. 42,044

CERTIFICATE OF SERVICE

Pursuant to 37 C.F.R. § 42.6(e), this is to certify that I caused to be served a

true and correct copy of the foregoing "NOTICE OF DEPOSITION OF DR.

CHRIS A. MACK, Ph.D." as detailed below:

Date of service April 8, 2015

Manner of service Email: andriy.lytvyn@smithhopen.com; <u>anton.hopen@smithhopen.com</u>; <u>IPR@smithhopen.com</u> <u>christopher.marando@weil.com</u>; <u>brian.ferguson@weil.com</u>

Persons Served Andriy Lytvyn and Anton Hopen Christopher Marando and Brian Ferguson

> /David M. O'Dell/ David M. O'Dell Registration No. 42,044